

U.S. PTO
09/27/01
09/27/01
09/27/01

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 011292	Serial No. New Appln.
	Applicants: Norihiko SEKINE	
	Filing Date: September 27, 2001	Group Art Unit: Not yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					
_____	AE					

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
<u>DNL</u>	AF 61-183915	08/16/1986	Japan	Abstract
<u>DNL</u>	AG 5-267790	10/15/1993	Japan	Abstract
<u>DNL</u>	AH 6-349692	12/22/1994	Japan	Abstract
_____	AI			
_____	AJ			

OTHER DOCUMENTS

<u>DNL</u>	AK	PATENT ABSTRACTS OF JAPAN; Publication No.: 06090061 A; Date of Publication: March 29, 1994. *Abstract Only*
<u>DNL</u>	AL	R.J. RAM et al.; <u>GaAs to InP Wafer Fusion</u> ; JOURNAL OF APPLIED PHYSICS; Vol. 78, pp 4227-4237; 1995
Examiner	Kang, Donghee	Date Considered 2-27-03